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**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700**

Attorney's Docket No. 015675.P568

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Bernard Beaumont, et al.

Application No. 10/522,397

Filed: October 21, 2005

For: **METHOD FOR PRODUCING BY
VAPOUR-PHASE EPITAXY A GALLIUM
NITRIDE FILM WITH LOW DEFECT
DENSITY**

Examiner: Robert M. Kunemund

Art Unit: 1792

Confirmation No.: 6314

AMENDMENT AND RESPONSE TO ADVISORY ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Advisory Action dated May 30, 2008, Applicants submit the following amendments and remarks: